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CEMARI	Assignee Micron Technology	/. Inc. LW IN
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	Group Art Unit	2830 (1)
	Examiner Unk	nown DV
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	Attorney's Docket No MI22	-1518 '
	Title: Capacitor Fabrication Methods and Capacitor Constructions	
	Title. Capacitor i abrication Methods and Capacitor Constructions	

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References -- See Attached Form PTO-1449

Assistant Commissioner for Patents Attn: Art Unit 2831 Washington, D.C. 20231

REMARKS

The Examiner's attention is directed to the references which are listed on the attached Form PTO-1449 and copies of which are attached. admission is made regarding whether all the submitted references are prior art.

	Citation of these paterits	is respectit	illy requeste	zu.
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